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Karen Cing-Mars
Karen Cing-Mars

(Signature)

6/3/02

(Date)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of : 2002
Mandelman et al. :
Serial No. Unassigned : Examiner:
Filed: IBM Corporation
Title: Backside buried strap Dept. 18G/Bldg. 300-482
for SOI DRAM trench capacitor 2070 Route 52
Hopewell Junction,
New York 12533-6531

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sirs:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to
the documents listed on the enclosed Form PTO-1449. Copies of the
listed documents are also enclosed.

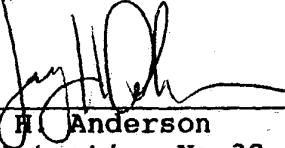
It is respectfully requested that the above information be
considered by the Examiner and that a copy of the enclosed Form
PTO-1449 be returned indicating that such information has been
considered.

Applicants' undersigned attorney may be reached by telephone
at (845) 894-3667. All correspondence should continue to be

directed to the below listed address.

Respectfully submitted,

By


Jay H. Anderson
Registration No. 38,371

INTERNATIONAL BUSINESS MACHINES CORPORATION
Intellectual Property Law Department
B/300-482
2070 Route 52
Hopewell Junction, New York 12533
Facsimile: (845) 892-6363

JHA/kcm

FIS920020038US1

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) FIS920020038		Application Number	
				Applicant(s) Mandelman et al.			
				Filing Date		Group Art Unit	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,238,967	05-29-01	Shiho et al.			
		6,066,527	05-23-00	Kudelka et al.			
		6,232,170	05-15-01	Hakey et al.			
		6,184,107	02-06-01	Divakaruni et al.			
		6,063,657	05-16-00	Bronner et al.			
		6,204,112	03-20-01	Chakravarti et al.			
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	WO 00/13225	03-09-00	PCT				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
		'Silicon VLSI Technology Fundamentals, Practice and Modeling' Plummer et al., Department of Electrical Engineering, Stanford University, Prentice Hall Pub., ppgs. 644-647					
EXAMINER				DATE CONSIDERED			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							